

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

TOKUSHIGE et al

Atty. Ref.: 900-406

Serial No. To Be Assigned

Group:

Filed: November 7, 2001

Examiner:

For: SEMICONDUCTOR DEVICE AND FABRICATION
PROCESS THEREFOR



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3-4-02
R. Stoken

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November 7, 2001

Assistant Commissioner for Patents
Washington, DC 20231

Sir:

INFORMATION DISCLOSURE STATEMENT

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached form PTO-1449, a copy of each of which is enclosed. This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.

The Examiner is requested to initial the attached form PTO-1449 and to return a copy of the initialed document to the undersigned as an indication that the attached references have been considered and made of record.

The undersigned attorney of record hereby certifies under 37 C.F.R. §1.97(e) that each item of information referenced herein and attached hereto was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,

NIXON & VANDERHYE P.C.

By: _____



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